

DATE: 12 SEP 1961 1504Z EPG IPT DEPTENT DMTCB
 (transponder) JA

Hydroxyethyl methacrylate

Feb, 2005

☒ DISCARD
 ☒ SEARCHED
 ☒ INDEXED
 ☒ FILED

	U	+	Inventor	Document	Issue P	Title	Curran	Current X	Retrieval	S	C	P	Y	Image Doc	P
1	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Kolachina, US	200500	2005 : 1	Focused ion beam endpoint detection	324/75			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 20050	
2	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Kane, Tere	US 667071	2003 : 1	Structure and method for charge sensi	257/777	257/48;		<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 66707	
3	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Hartswick, US	662792	2003 : 1	Method of designing and structure for	257/21	257/48;		<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 66279	
4	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Chandler, US	621152	2001 : 1	Method for device editing	250/49	257/E21.2		<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 62115	
5	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Hamann, H	US 200500	2005 : 2	SYSTEM AND METHODS OF ALTERI	216/82			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 20050	
6	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Hamann, H	US 200500	2005 : 9	SYSTEM AND METHOD OF ALTERIN	216/57			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 20050	
7	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Suthar, Sail	US 200402	2004 : 9	Interconnect routing over semiconduct	257/48			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040	
8	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Huynh, Ch	US 200402	2004 : 1	Dummy copper deprocessing	438/72			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040	
9	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Herschbein	US 200401	2004 : 1	DRY ETCH PROCESS TO EDIT COPP	218/39			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040	
10	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	Marchman, US	200401	2004 : 2	APPARATUS AND TECHNIQUES FOR	250/49			<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	<input checked="" type="checkbox"/>	US 20040	